

LIST OF PRIOR ART CITED BY APPLICANT
(Filed on February 23, 2004)

Docket No. GK-OEH-178 / 500814.20080

Applicant(s): Duc Chinc TRAN and Juergen KLEINSCHMIDT

Application No.

Filed: concurrently herewith -February 23, 2004

Group: 2851

Examiner: Rutledge

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub- Class	Filing Date Appropriate
D.R	AA	6,359,969	03/19/2002	Shmaenok	378	156	
D.R	AB	6,377,651	04/23/2002	Richardson, et al.	378	34	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub- Class	Translation YES NO
D.R	AL	102 15 469	11/06/2003	Germany	—	—	US 2003/0190012
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						
	AS						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

D.R	AV	Proceedings of SPIE, Vol. 4146 (2000) pgs. 128-131, Yamamoto et al. "Compact Debris Shutter Design of a laser-Produced Plasma Source for High NA Application"
	AW	
	AX	
	AY	
	AZ	

Examiner: <i>Rutledge</i>	Date: 3/6/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



(2nd)
LIST OF PRIOR ART CITED BY APPLICANT
(Filed on October 26, 2004)

Docket No. 5K-OEH-178 / 500814.20080

Applicant(s): Duc Chinc TRAN and Juergen KLEINSCHMIDT

Application No. 10/784,438

Filed: February 23, 2004

Group: ~~288~~ 2851
Examiner: Rutledge

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub- Class	Filing Date Appropriate
<i>D.R.</i>	AA	6,285,737	09/04/2001	Sweatt, et al.	378	85	
<i>D.R.</i>	AB	2003/0020890	01/30/2003	Ogushi, et al.	355	53	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub- Class	Translation YES NO
<i>D.R.</i>	AL	WO 02/27406	04/04/2002	WIPO	-	-	
<i>D.R.</i>	AM	101 36 620	02/06/2003	Germany	-	-	Abstract only
<i>D.R.</i>	AN	101 28 284	02/27/2003	Germany	-	-	Abstract only
	AO						
	AP						
	AQ						
	AR						
	AS						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AV	
AW	
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AZ	

Examiner: *Rutledge*

Date: 9/6/05

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